

Patent Assignment Abstract of Title

Total Assignments: 1

Application #: 09884906

Filing Dt: 06/21/2001

Patent #: NONE

Issue Dt:

PCT #: NONE

Publication #: NONE

Pub Dt:

Inventors: Tae-Ho Yoon, Joon Ho Roh

Title: Surface modified silica by plasma polymerization, preparation method and apparatus thereof

Assignment: 1

Reel/Frame: 012256/0335

Received:
10/22/2001

Recorded:
10/15/2001

Mailed:
12/26/2001

Pages: 3

Conveyance: ASSIGNMENT OF ASSIGNORS INTEREST (SEE DOCUMENT FOR DETAILS).

Assignors: YOON, TAE-HO

Exec Dt: 05/02/2001

ROH, JOON HO

Exec Dt: 05/02/2001

Assignee: KWANGJU INSTITUTE OF SCIENCE AND TECHNOLOGY

ORYONG-DONG 1, BOOK-KU

KWANGJU, KOREA, REPUBLIC OF

Correspondent: FINNEGAN, HENDERSON, FARABOW, ET AL.

ERNEST F. CHAPMAN

1300 I STREET, N.W.

WASHINGTON, DC 20005-3315

Search Results as of: 1/8/2003 6:56:05 P.M.

If you have any comments or questions concerning the data displayed, contact OPR / Assignments at 703-308-9723
Web interface last modified: Oct. 5, 2002